

 <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>				Docket Number (Optional) YPL-0069		Application Number 10/716,950		
				Applicant(s) Young Hoon PARK, et al.				
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U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
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FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
KMS		2001-0065160	7-11-2001	KOREA				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
		An Office Action issued by Korean Patent Office dated November 18, 2004, regarding corresponding Korean Patent Application No. 10-2002-0072380						
EXAMINER /Kelly Stouffer/					DATE CONSIDERED 08/14/2006			
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